

Sapienza Università di Roma  
Dipartimento di Fisica  
PhD school in accelerator physics XXX cycle

3<sup>rd</sup> year admission talk

Proposed title:

**“Advanced beam diagnostics and beam protection  
for high-brightness electron-beam”**

**Supervisor:** Luigi Palumbo

**Co-supervisor:** David Alesini

# Outline

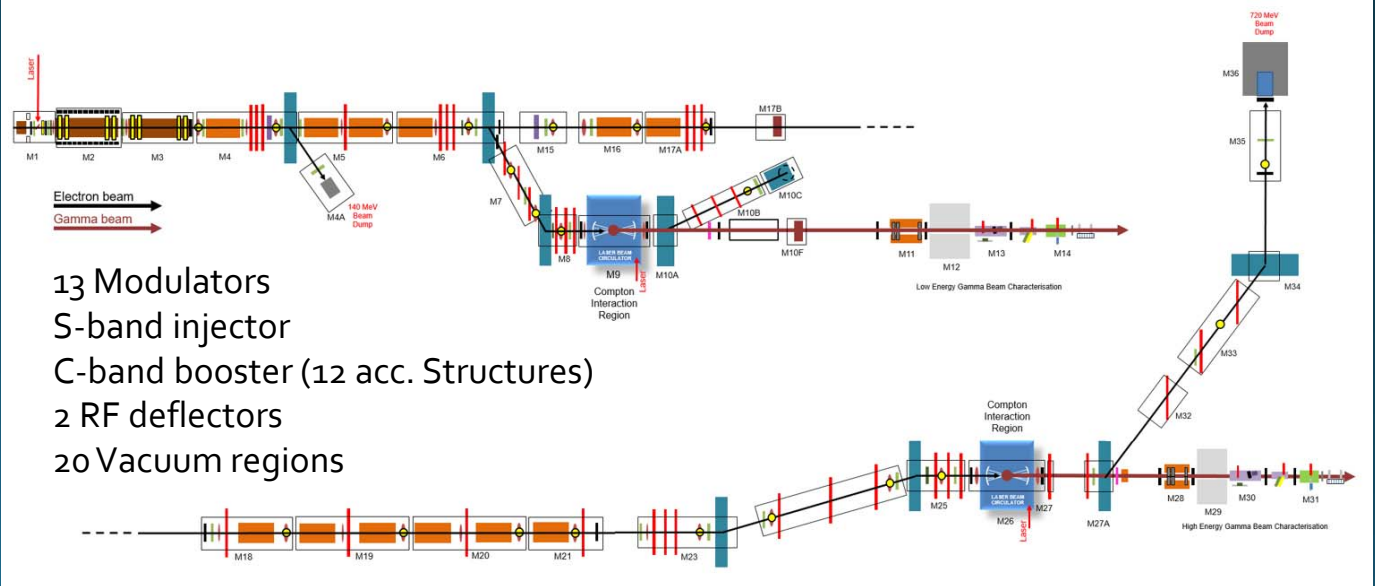
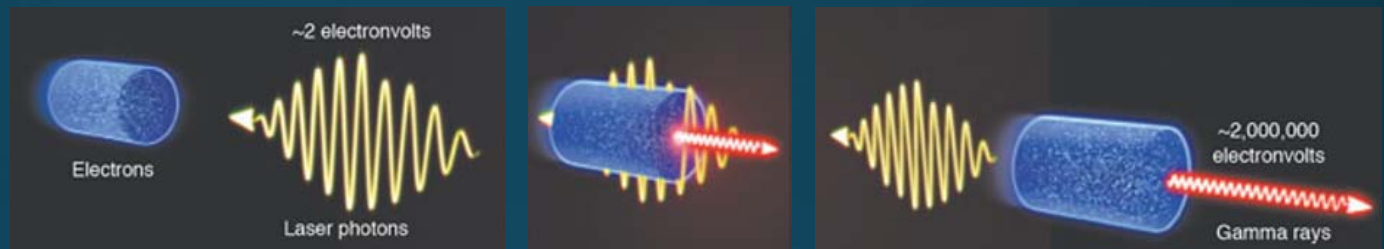
- ELI-NP GBS overview and layout
- Machine Protection System
  - Architecture design
  - Fast-Interlock
    - Real-time waveform mask
  - Magnets and Vacuum PLCs
  - Supervisor
    - Distributed Cherenkov Beam Loss Position monitor
    - Hall probe monitor
  - Next steps
- Electron beam performance monitor

# ELI-NP Gamma Beam Source

Gamma beam params	
Energy	0.2 – 20 MeV
Spectral density	$0.8 - 4 * 10^4 \frac{ph}{s * eV}$
Bandwidth (RMS)	< 0.5 %
Peak brilliance	$> 10^{20} \frac{ph}{s * mm^2 * mrad^2 * 0.1\%}$
Spot size	10 – 30 $\mu m$

Electron beam params	
Energy	75 – 740 MeV
Bunch charge	25 – 400 pC
Number of bunches/pulse	32
Bunch distance	16 ns
Bunch length	100 – 400 $\mu m$
Pulse length	512 ns
Energy spread (RMS)	0.04 – 0.1%
Norm. Emittance	0.4 mm * mrad
RF repetition rate	100 Hz

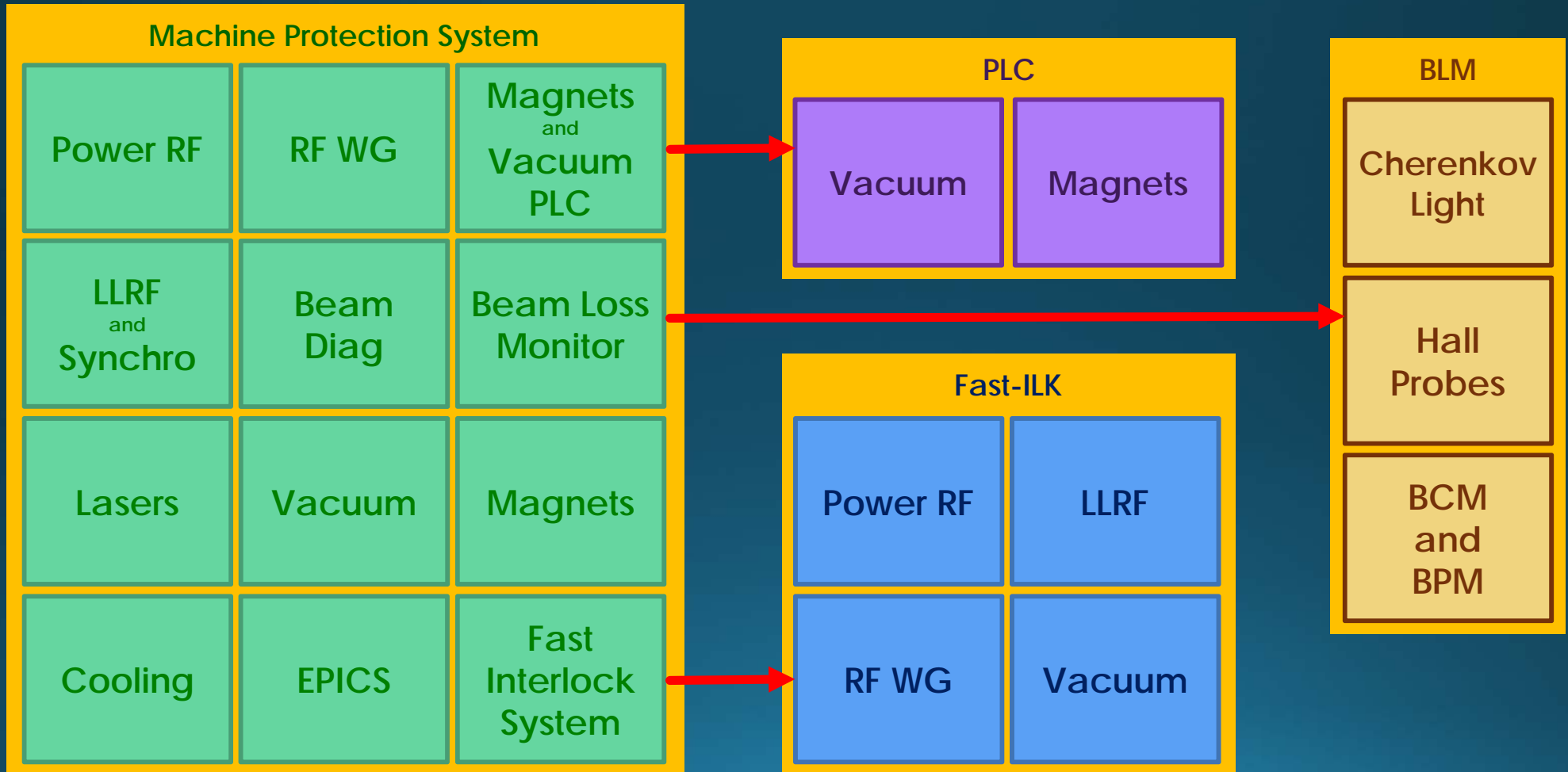
Compton back-scattering gamma source from the interaction of an high brightness electron beam and high power laser pulse.



# MPS: Architecture design

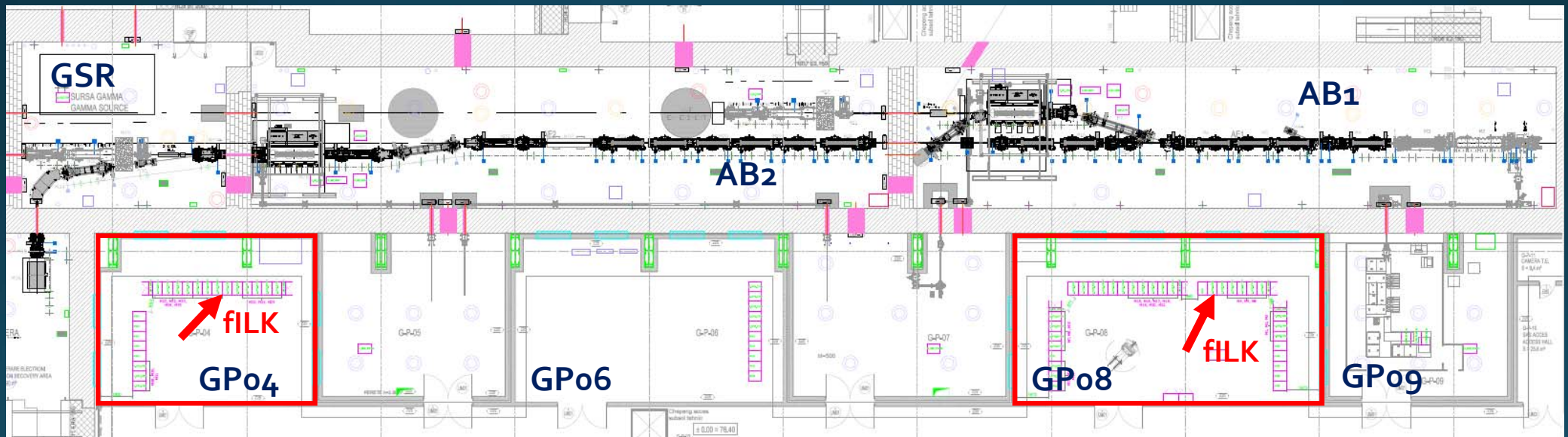
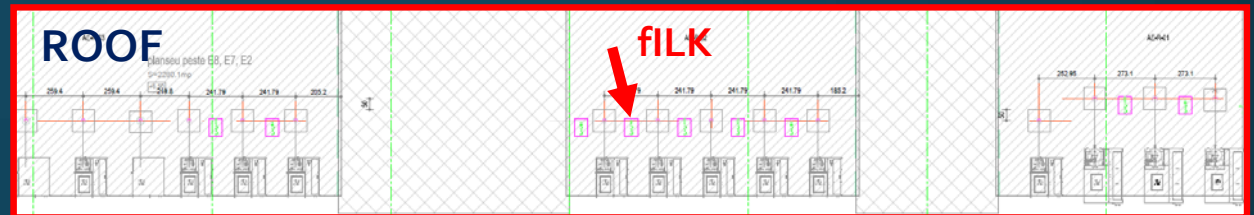
- **Integrated with all machine sub-systems**
- **Fast response** to protect critical system (less than 10 ms)
- **Robust** with a failsafe design and rich self-diagnostics
- **Smart** configurable logic matrix
- **Flexible** easily modify, extend and optimize

# MPS: Architecture design



# MPS: Fast-Interlock system topology

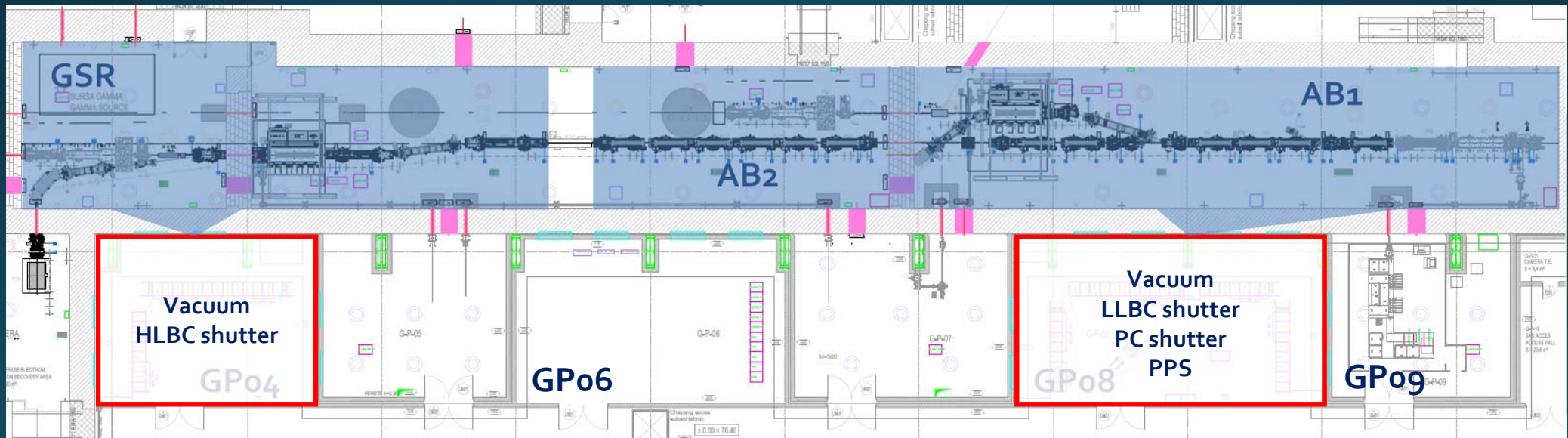
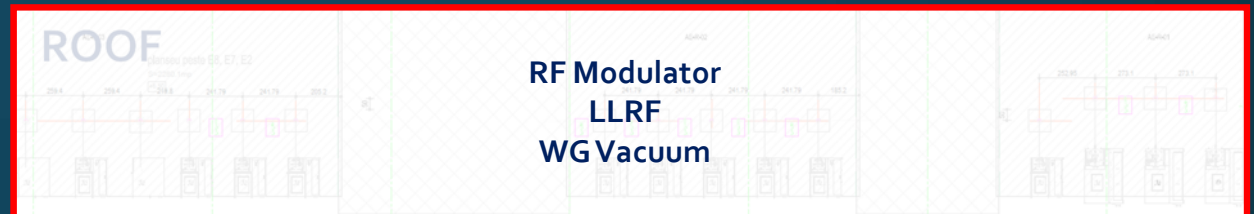
- real-time FPGA-based
- distributed I/O framework
- hardwired to critical system
- avoid single point of failure





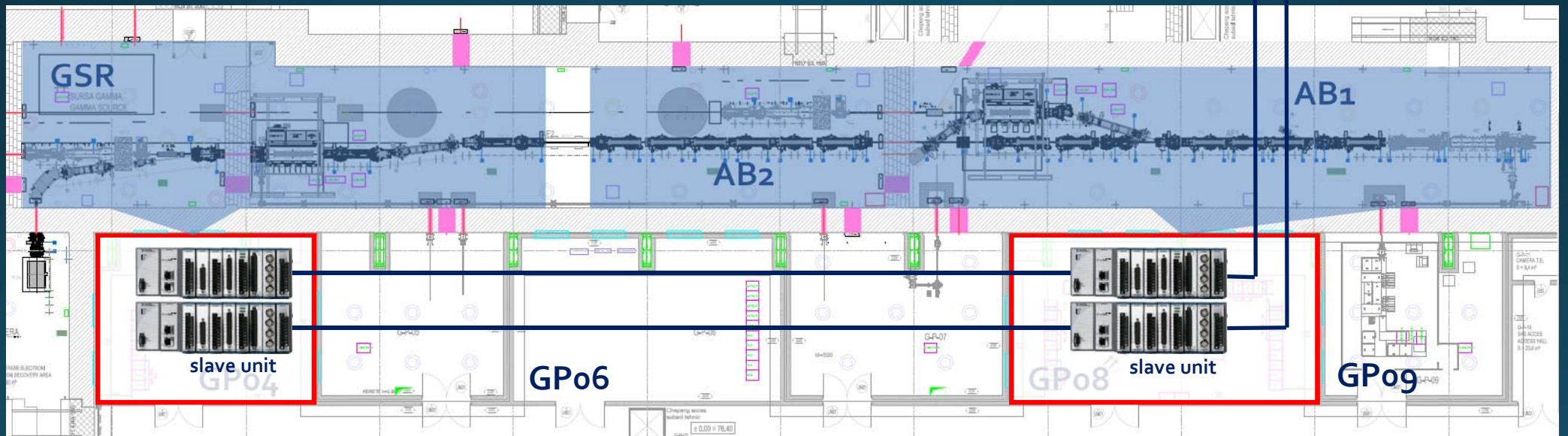
# MPS: Fast-Interlock system topology

- real-time FPGA-based
- distributed I/O framework
- hardwired to critical system
- avoid single point of failure



# MPS: Fast-Interlock system topology

- real-time FPGA-based
- distributed I/O framework
- hardwired to critical system
- avoid single point of failure





# MPS: Fast-Interlock performance

- **Principal features:**

- Each Fast-ILK system monitors a region of vacuum from different gauges and ion-pumps then if one of these has a failure this affects only one Fast-ILK system.
- The Fast-ILK system handles vacuum events from accelerating cavities, WGs, LBCs, Gamma diag. and transfer lines.
- The Fast-ILK system provides safe procedures for modulators conditioning or normal operation operating on LLRF.
- The Fast-ILK system try to dissect the vacuum region where a vacuum leak is detected and closing the RF Gun valve.
- The Fast-ILK system operates as front-end of Personnel Protection System for RF systems.

- **Performance:**

- EtherCAT network latency: less then 100  $\mu$ s (jitter less then 1  $\mu$ s)
- Detection time:
  - Vacuum gauges: ~20 ms
- **Execution time (Fast-ILK): less than 1 ms**
- Execution time (devices):
  - Modulator: + 10  $\mu$ s,
  - LiberaLLRF: + 10  $\mu$ s,
  - Lasers shutters: (TBD),
  - Pneumatic valves: + 25 ms (PLC) + 1 / 2 s (for DN40/63 valves)

# MPS: Fast-Interlock WFM mask

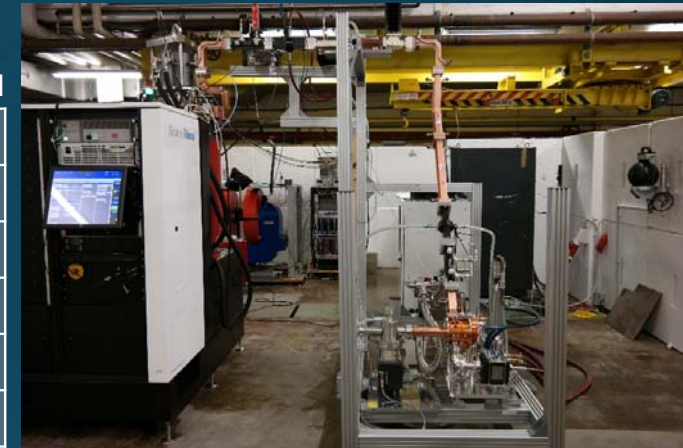
**Scope of work:** monitor real-time RF-signals to detect anomalous vacuum activity in WG and accelerating structures and operate RF systems in less than 10 ms.

## Specifications:

- Sample real-time 1,5  $\mu$ s reflected RF signal from a directional coupler;
- Analyze sampled signal;
- Trip RF Modulator in less than 10 ms.

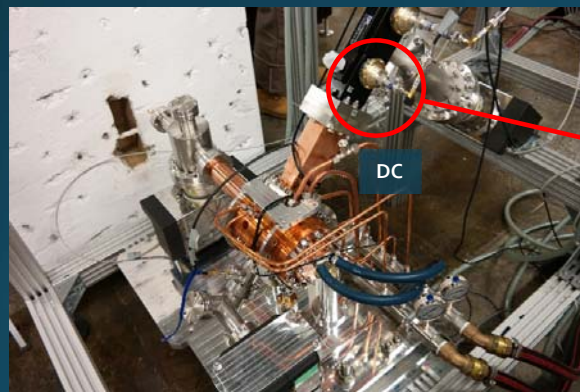
## ELI-NP RF-GUN

Rep. Rate	100 Hz
Working mode	$\Pi$ mode (SW)
Max RF input	16 MW
RF peak field	120 MV/m
Filling time	420 ns
Unloaded Q factor	15000

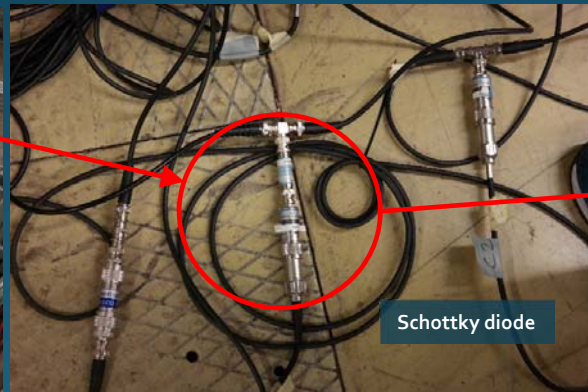


RF-Gun conditioning Bonn 12/2015

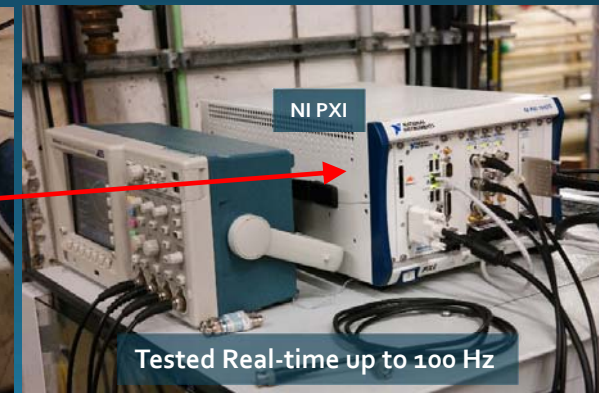
Prototype



DC



Schottky diode



Tested Real-time up to 100 Hz

## Digitizer specs:

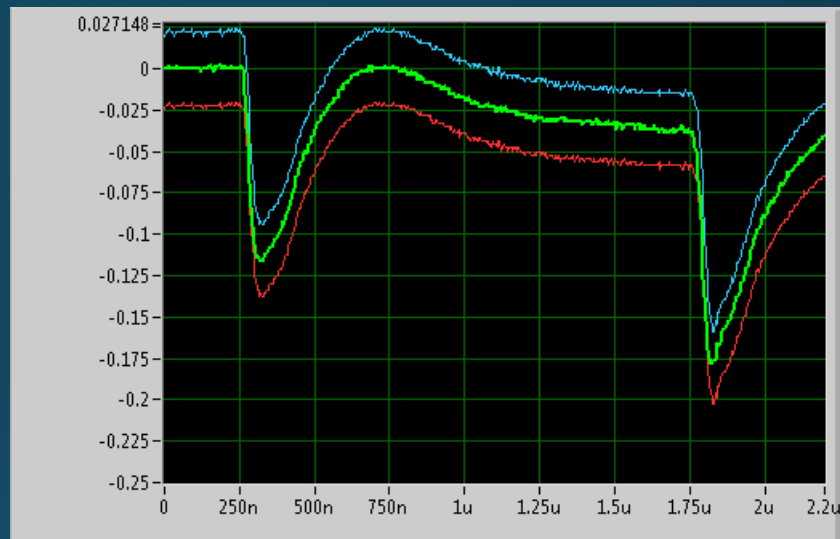
Sampling Rate	2 GS/s
Sample depth	10-bit
BW	1,5 GHz
Memory	16 MB
Cost/channel	7,5 k€

# MPS: Fast-Interlock WFM mask

**Scope of work:** monitor real-time RF-signals to detect anomalous vacuum activity in WG and accelerating structures and operate RF systems in less than 10 ms.

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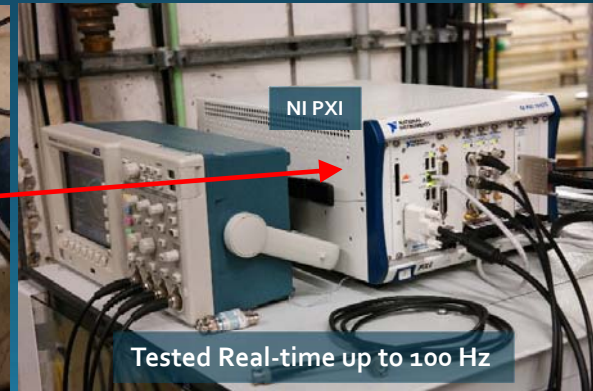
- Sample real-time 1,5  $\mu$ s reflected RF signal from a directional coupler;
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- Trip RF Modulator in less than 10 ms.



Healthy signal

Upper mask  
Lower mask  
Reflected RF

Prototype



## Digitizer specs:

Sampling Rate	≥ 2 GS/s
Sample depth	10-bit
BW	1,5 GHz
Memory	16 MB
Cost/channel	7,5 k€

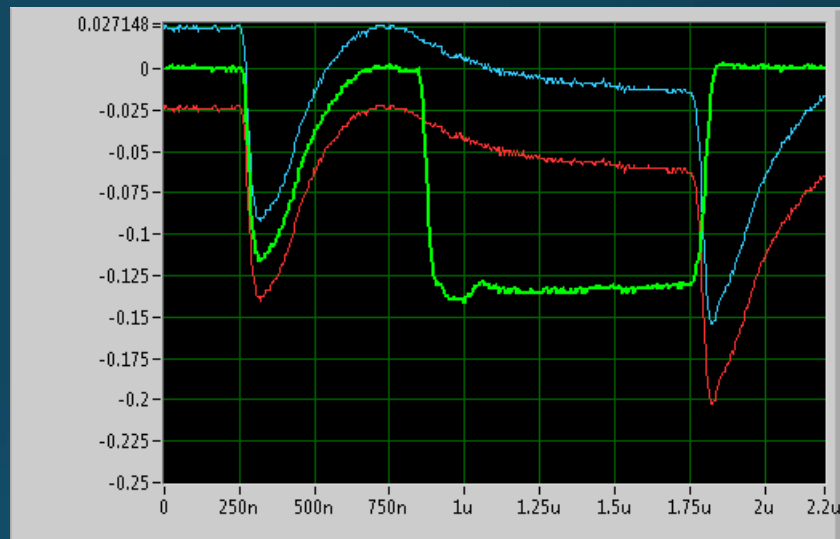


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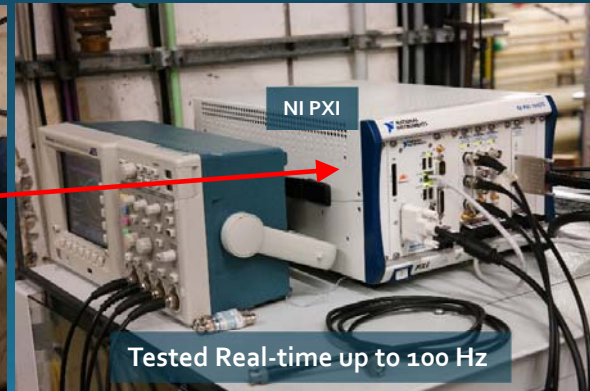
- Sample real-time 1,5  $\mu$ s reflected RF signal from a directional coupler;
- Analyze sampled signal;
- Trip RF Modulator in less than 10 ms.



Bad signal

Upper mask  
Lower mask  
Reflected RF

Prototype



## Digitizer specs:

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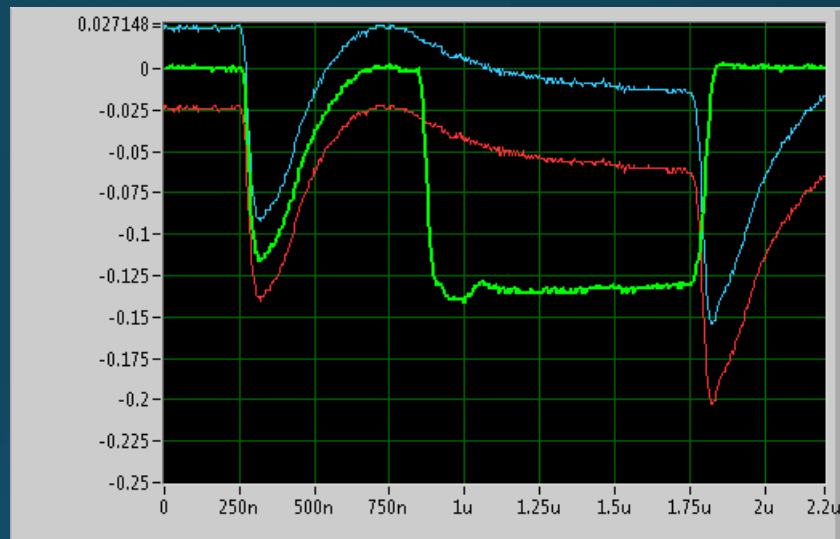
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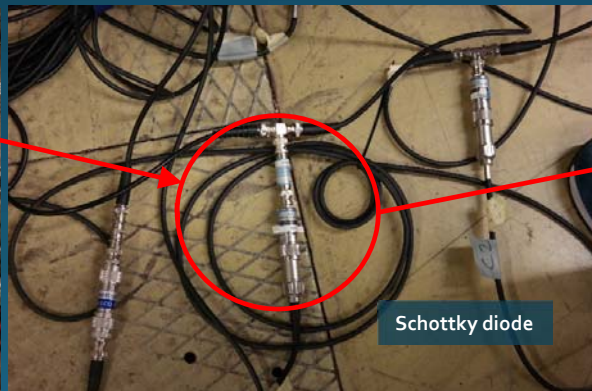
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Bad signal

Upper mask  
Lower mask  
Reflected RF

Final design



## Digitizer specs:

Sampling Rate	3,2 GS/s
Sample depth	12-bit
BW	0,5 GHz
Memory	128 B
Cost/channel	400 €



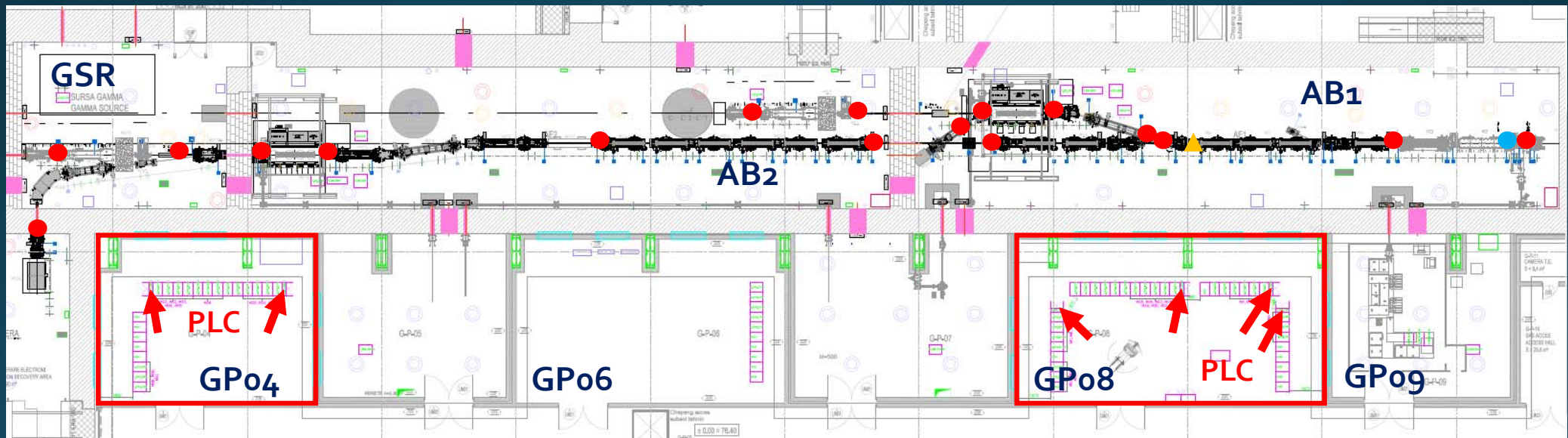
# MPS: Magnets and Vacuum PLCs

## Specifications:

- 20 Omron PLC distributed among the technical rooms.
- 20 Vacuum regions
- 17 valves driven from boundary vacuum gauges.
- Interfaced with the EPICS network and Fast-ILK.
- VAT Fast Closing Valve system in M1 with dedicated vacuum gauge in M6 (distance ~16 m).

## Performance:

- Detection time:
  - Vacuum gauges: ~60 ms,
  - Fast Valve vacuum gauge: 2 ms
- Execution time:
  - ~25 ms + 1/2 s (for DN40/63 valves),
  - Fast Valve shutter: 5 ms (able to stop shockwave from both interaction point: from gauge to shutter a Mach-2 shockwave require 30 ms).



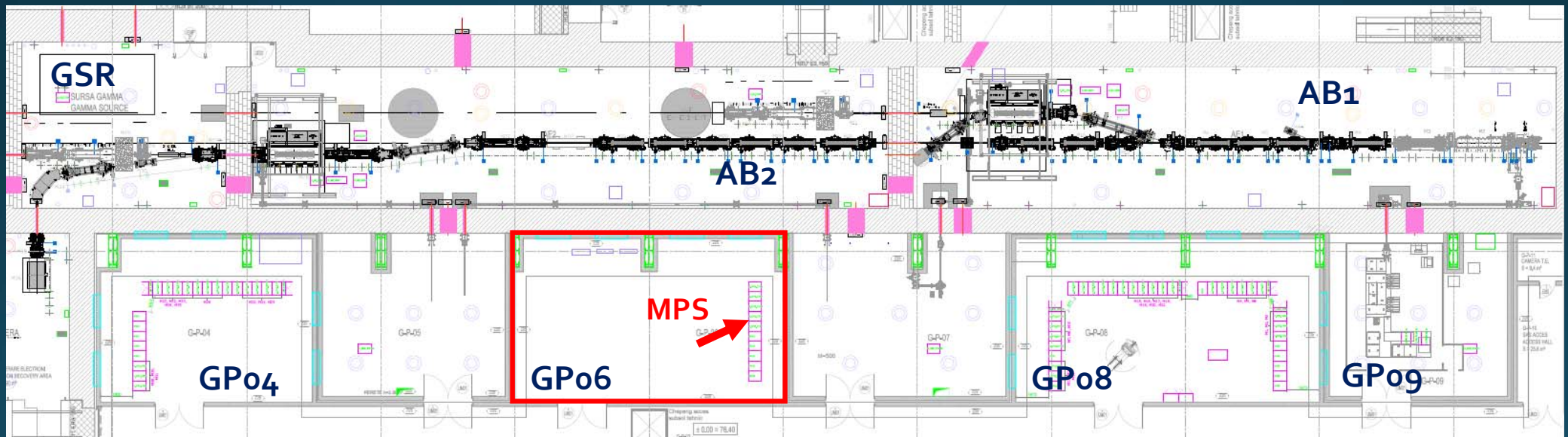
# MPS: Supervisor

## Specifications:

- 1 + 1 (auxiliary) IOC running in parallel servers.
- Integrated in the EPICS network: able to reach all sub-systems.
- Interfaced with MPS sub-systems:
  - interlock hardware (Fast-ILK and PLCs)
  - Interlock software (EPICS)
  - BLMs

## Performance:

- EPICS network latency: ~100 ms,
- Execution time: less than 10 ms



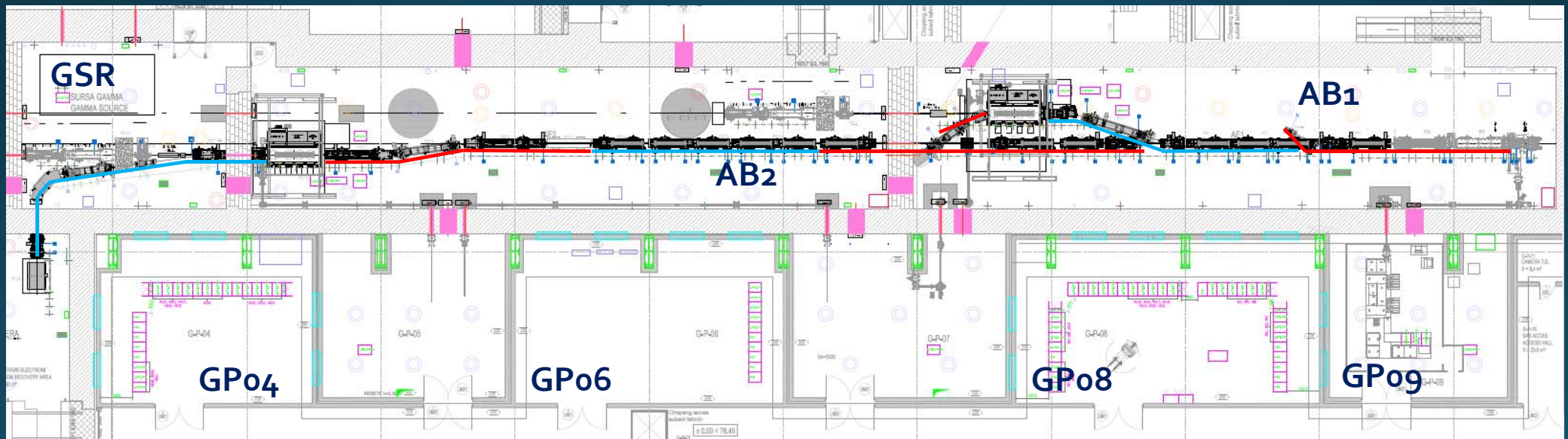
# MPS: Supervisor Distributed Chernkov BLPM

**Scope of work:** map beam loss along whole accelerator to enable operation for machine and personnel safety.

**Specifications:**

- Locate beam loss and the involved device of lattice.
- Trip RF-Gun and Photo Cathode laser.

Split the facility in different trunk (max. length of 20 m) avoid background saturation due to the dark current transport.





# MPS: Supervisor Distributed Cherenkov BLPM

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$$\cos \theta_c(\lambda) = \frac{1}{\beta n(\lambda)}$$

Cherenkov cone semi-angle

$$\cos 0 = \frac{1}{\beta n(\lambda)} \quad \beta = \frac{1}{n} \approx 0,7$$

Cherenkov energy threshold

$$\theta_c = \begin{cases} 17^\circ & \text{if } \beta \approx 0,7 \\ 48^\circ & \text{if } \beta \approx 1 \end{cases}$$

$$\varphi < \varphi_{max} = \sin^{-1} \frac{NA}{n} = 8,4^\circ$$

Total internal reflection limit angle

$$\theta = \begin{cases} [8,6^\circ - 25,4^\circ] & \text{if } \beta \approx 0,7 \\ [40,6^\circ - 56,4^\circ] & \text{if } \beta \approx 1 \end{cases}$$

Charged particles angle through the fiber  
(to be trapped from sensor side, other side is suppressed by critical angle cut)

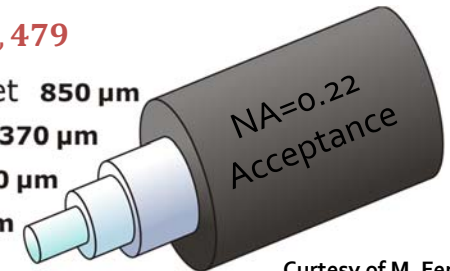
Core refractive index:  $n = 1,479$

nylon jacket  $850 \mu\text{m}$

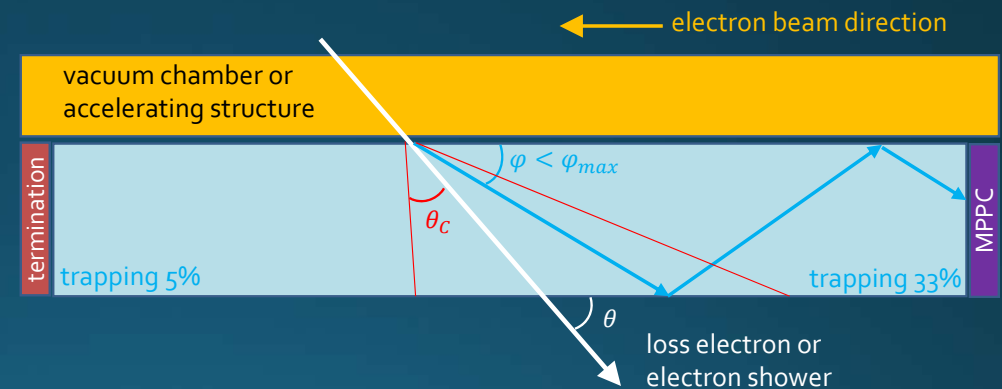
polyimide buffer  $370 \mu\text{m}$

fluorine silica cladding  $330 \mu\text{m}$

high OH silica core  $300 \mu\text{m}$



Courtesy of M. Ferianis



$$\frac{dN}{dx d\lambda} = \frac{2\pi\alpha}{\lambda^2} \sin^2 \theta_c = \begin{cases} 2 \frac{ph}{mm} & \text{if } \theta_c = 17^\circ \\ 13 \frac{ph}{mm} & \text{if } \theta_c = 48^\circ \end{cases}$$

Cherenkov photons from a single charged particle

$\lambda = [400 \text{ nm} - 500 \text{ nm}]$

Light wavelength

$\alpha$   
Fine structure constant

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## Specifications:

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"The WaveCatcher family of SCA-based 12-bit 3.2 GS/s fast digitizers"

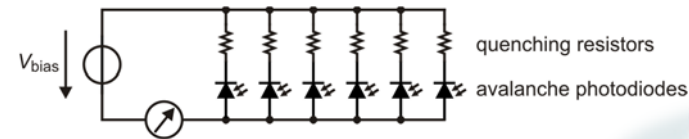
D. Breton, E. Delagnes, J. Maalmi, P. Rusquart

$$\Delta s = \Delta t \, c \left( \frac{1}{\beta} + n \right)^{-1} \quad \text{Optical fiber nominal longitudinal resolution}$$

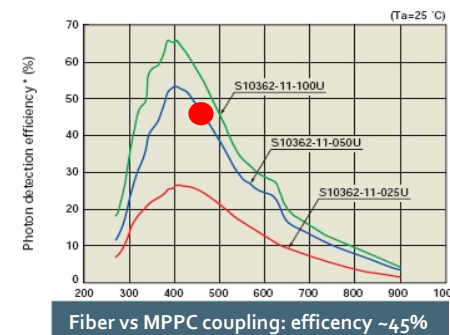
**@3,2 GS/s time-of-flight resolution ~4 cm**

## Digitizer specs:

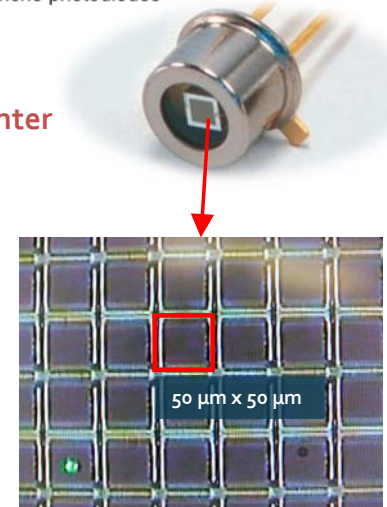
Sampling Rate	3,2 GS/s
Sample depth	12-bit
BW	0,5 GHz
Memory	128 B
Cost/channel	400 €



## Hamamatsu Multi-Pixel Photon Counter



Fiber vs MPPC coupling: efficiency ~45%



- Array of 400 avalanche photodiodes (APDs) connected in parallel
- Reverse bias (photon causes APD breakdown)
- Photomultiplier-like gain ( $10^5 - 10^6$ )
- Insensitivity to magnetic field
- Time resolution: rise time 100 ps
- Compact and Low cost



# MPS: Supervisor Distributed Cherenkov BLPM

**Scope of work:** map beam loss along whole accelerator to enable operation for machine and personnel safety.

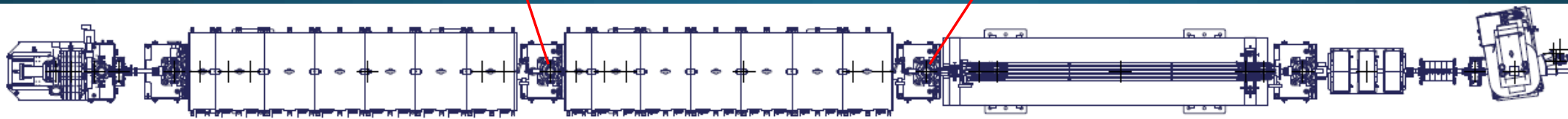
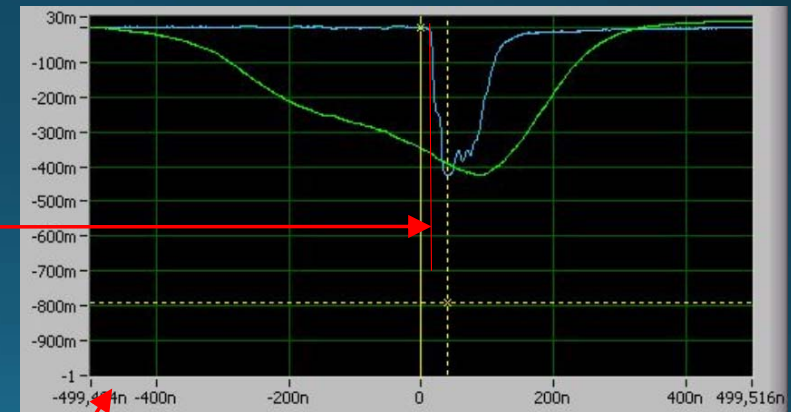
## Specifications:

- Locate beam loss and the involved device of lattice.
- Trip RF-Gun and Photo Cathode laser.

## Distance between AC<sub>2</sub>FLAG and AC<sub>3</sub>FLAG

Distance from CAD	3,5 m
Time-of-flight difference	~ 30 ns
Reconstructed distance from Cherenkov BLPM	~ 3,6 m
Sampling rate	1 GS/s
DAQ accuracy	+/- 15 cm

Prototype  
@SPARC\_LAB

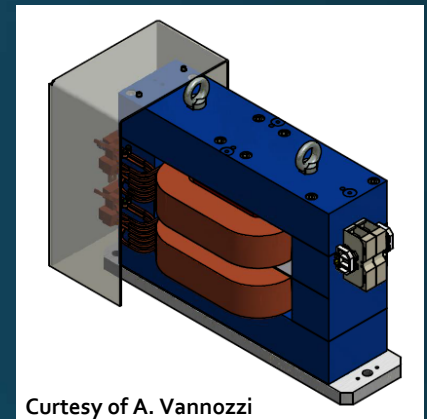
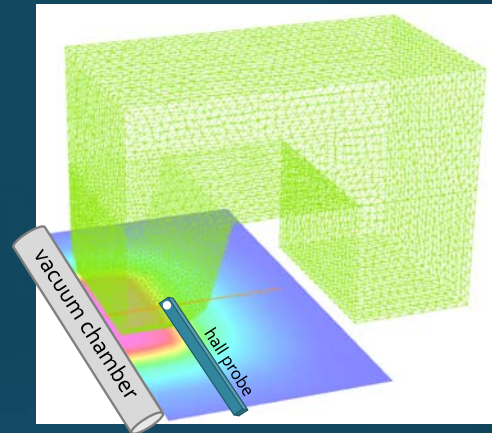


# MPS: Supervisor Hall Probes

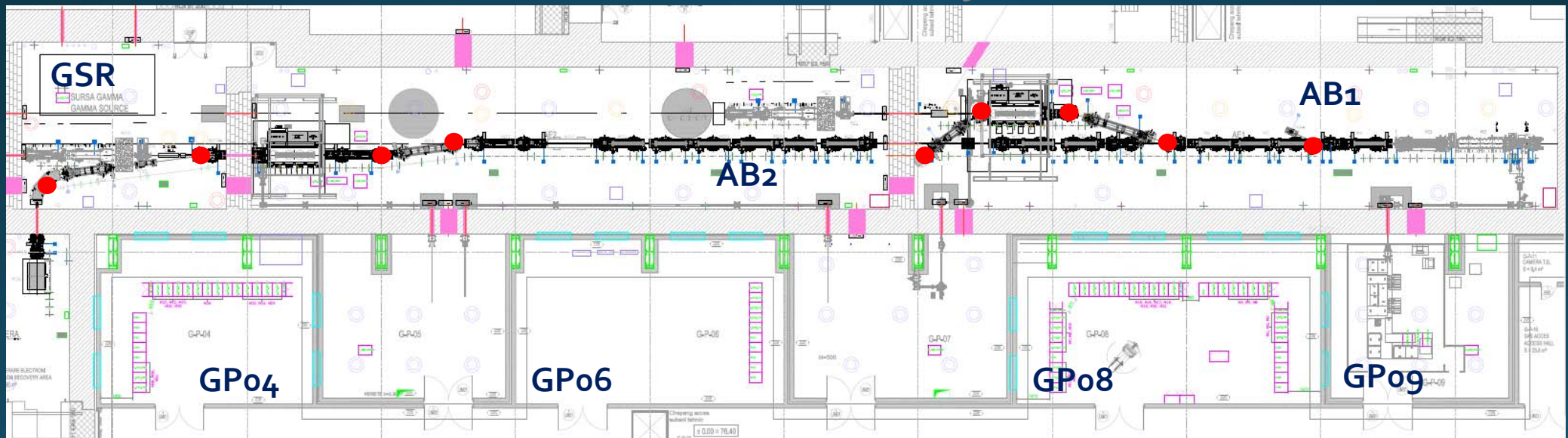
**Scope of work:** monitor B field inside the 9 dipoles to verify the matching between magnet field and power supply current set-point.

## Specifications:

- Acquire bipolar B field between 0.4 T and 1.6 T;
- Convert probe signal from raw data to supplied current.
- Trip RF-Gun and Photo Cathode laser.



Courtesy of A. Vannozzi

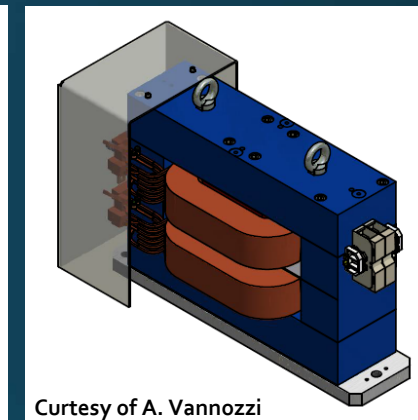
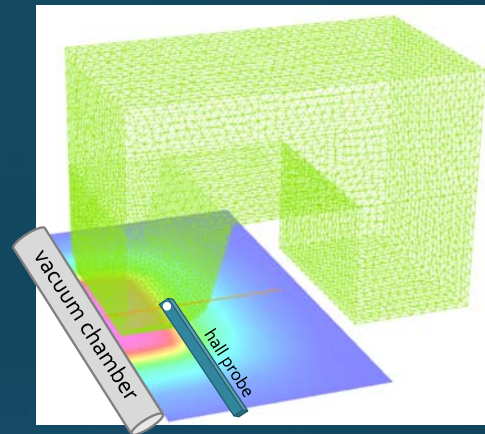


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Courtesy of A. Vannozzi

## Hall probe specs:

Full scale	+/- 2 T
Signal Amplitude	+/- 10 V
BW	200 kHz
Noise	< 1 mV <sub>p-p</sub>
Working temp.	10 - 50 °C

## DAQ specs:

Signal Amplitude	+/- 10 V
Sample depth	16-bit
BW	10 MHz
Accuracy	+/- ~2 mV
Accuracy (B field)	+/- ~4 G

## 1 Calibration

Lookup table to convert from signal amplitude to magnetic field.

## 2 Calibration

Dipole excitation curve (provided by manufacture) to convert magnetic field to supplied current.

## Monitor

Check mismatch between power supply and Hall probe current set-point.

# MPS: Next Steps

- Fast-ILK – Finalize FPGA software development
- Waveform Mask – ready!
- Supervisor – Finalize software development
- Cherenkov BLPM – Calibrate all optical fiber + MPPC setups with a pulser
- Hall probes – Calibrate probe + magnet + power supply
- **Tuning and Site Acceptance Test**

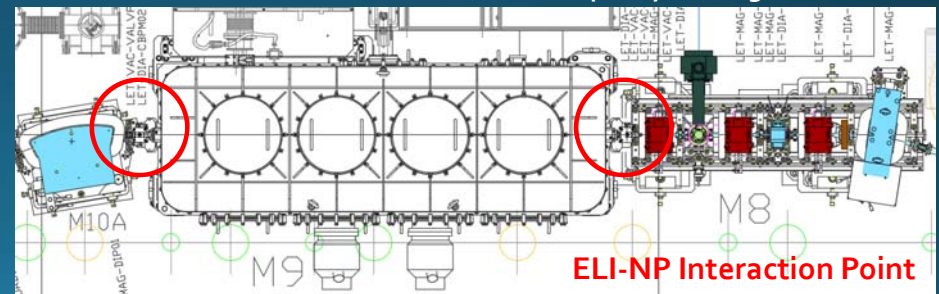
# Electron beam performance monitor

- Scope of work:
  - Electron beam current monitor
  - Electron beam position monitor
  - Electron beam sigma monitor
  - Non-intercepting measure
  - Low-Q to measure multi-bunch beams (ELI-NP like)
  - Real time

- EM Design
- Mechanical design
- Test

Next year!

This device can monitor the electron beam just before and after the IP to handle the quality of the gamma source





Thank you for the attention.